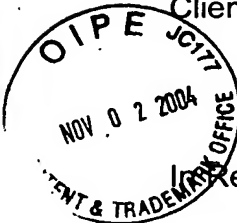


IFE

Docket Number: 081468-0306882  
Client Reference: P-1741.000-US

PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re the Application of

STREEFKERK et al.

Group Art Unit: 2851

Application No.: 10/719,683

Examiner: TBA

Filed: November 24, 2003

Confirmation No.: 1907

For: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

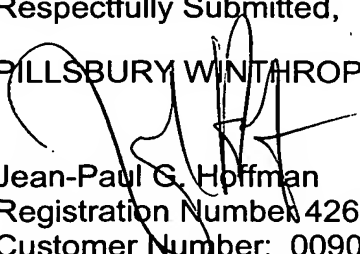
Pursuant to 37 CFR 1.56, the attention of the Patent and Trademark Office is hereby directed to the reference(s) listed on the attached PTO-1449. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The undersigned respectfully notes that copies of U.S. references are not required in applications filed after June 30, 2003

This Information Disclosure Statement is being filed before the mailing date of the first Office Action on the merits in the present application. No certification or fee is required.

Respectfully Submitted,

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FORM PTO-1449 (modified)  
To: U.S. Department of Commerce  
(PW FORM PAT-1449)  
Patent and Trademark Office



Atty.  
Dkt. No.

M#

Client Ref.

306882

P-1741.000-US

**INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT**

Applicant: STREEFKERK et al.

Appln. No. 10/719,683

Filing Date: November 24, 2003

Date: November 2, 2004

Page 1 of 1

Examiner: Unknown

Group Art Unit: 2851

**U.S. PATENT DOCUMENTS**

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ZR								

**OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)**

AAR				
BBR				
CCR				

Examiner

Date Considered:

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.